

In re the Application of: Tetsuya IKUTA et al.

Group Art Unit: 2814

Application Number: 10/809,809

Examiner: Thao X. Le

Filed: March 26, 2004

Confirmation Number: 7816

For: SEMICONDUCTOR MANUFACTURING METHOD FOR IMPROVING CARRIER MOBILITY AND REDUCING LEAK CURRENT (AS AMENDED)

Attorney Docket Number:

042278

Customer Number:

38834

AMENDMENT UNDER 37 C.F.R. §1.114

Mail Stop: RCE

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 September 24, 2007

Sir:

This Submission is being filed concurrently with a Request for Continued Examination pursuant to 37 C.F.R. §1.114, and is also in response to the Office Action dated April 25, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.